

Class	Subclass
ISSUE CLASSIFICATION	

U.S. UTILITY Patent Application

O.I.P.E.

PATENT DATE

SCANNED Eden 3 o.a. A.G.

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/818625	F	396 355	33	2851	<i>Deane H. H.</i>

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TITLE

Exposure apparatus, gas replacement method, semiconductor device
manufacturing method, semiconductor manufacturing factory and
entire apparatus maintenance method

PTO-2040
12/99

[illegible]

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS Sheets Drwg. Figs. Drwg. Print Fig.		CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed. <input checked="" type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S. Patent. No. _____ _____ _____	_____ (Assistant Examiner) (Date) _____ (Primary Examiner) (Date)		NOTICE OF ALLOWANCE MAILED _____	
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			Amount Due	Date Paid
<input type="checkbox"/> The terminal _____ months of this patent have been disclaimed.	_____ (Legal Instruments Examiner) (Date)		ISSUE BATCH NUMBER	

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